

Introduction

Consider a response surface on a given real domain D (usually a rectangle). A measurement is available at each testing points $x \in D$. We want to assess the conformity of the shape of the response surface to some standard. For example: "is the surface bended in some direction?" Or: "Is there a waviness of a type associate to a specific technology?" These are possible defects that cannot be specified in a parametric way [5, 6].

A very popular modeling method relies on the assumption that the surface under study is the realization of a random field, for example, a Gaussian random field $(\zeta_{\chi})_{\chi \in D}$. In such a case, the observed characteristics of the surface will in fact depend on the auto-covariance of the random field.

Empirical variograms

Giovanni Pistone

Collegio Carlo Alberto

• If F is linear, $F(x) = a \cdot x$, then $|F(v + u) - F(v)|^2 = (a \cdot u)^2$ and the defining equation becomes

$$\begin{split} \Phi(t)\gamma(t) \ \nu(dt) &= \\ \int_{D} \Phi(\|u\|) \frac{1}{2} (a \cdot u)^{2} \ du dv \ . \end{split}$$

5 If F is Lipschitzs, we can derive an upper bound for the variogram. In fact,

 $|F(v + u) - F(v)|^2 \le ||F||_{Lip}^2 ||u||^2$,

implies

$$\gamma(t) \leq rac{1}{2} \left\| \mathsf{F}
ight\|_{\mathsf{Lip}}^2 t^2$$
 .



Superposed functions

The variogram of $F_1 + F_2$ appears to be difficult to undestand in terms of the separate variograms because there is an interaction term:

$$\gamma_{1+2} = \gamma_1 + \gamma_2 + \gamma_{12} ,$$

where $\gamma_{1,2}$ is defined by the polarised version of the definition of γ . Here are two examples.

$$F(x) = \frac{1}{4}x + \sin(6(2\pi)x)$$

$$\begin{bmatrix} 1.4 \\ 1.2 \end{bmatrix} = \left(\begin{array}{c} 1.4 \\ 1.2 \end{array} \right) \left(\begin{array}{c} 1.4 \\ 1.4 \end{array} \right) \left(\begin{array}{c} 1.4 \end{array} \right) \left(\begin{array}{c} 1.4 \\ 1.4 \end{array} \right) \left(\begin{array}{c} 1.4 \end{array} \right) \left($$

More specifically, under the intrincic stationarity assumpion $\mathbb{E}(\zeta_x) = \mathfrak{m}$ and $\mathbb{E}(|\zeta_x - \zeta_y|) = \gamma(\mathfrak{d}(x,y))$, the properties of the random surface depend on the random field variogram γ [1]. This approach is sometimes called Kriging method or Matheron method and can be used both in a parametric or non-parametric approach. Cf. [2, 3, 4].

G. Vicario has suggested in [7] to use the variogram as a non-parametric method, without assuming any randomness of the surface, but using instead the idea of a sistematic or random sampling of couples of test points on the given domain.

Methodology

The following definition is intended to mimic the definition of the Matheron empirical estimator of the variogram. **Definition** Let X and Y be independent random variables

Examples

With D =]0, 1[and uniform X, Y, we show below the function F and a graph of $\sqrt{2\gamma}$.

Affine: $F(x) = 1 + \frac{1}{4}x$







Acknowledgements

whose common distribution μ is supported by the domain $D \in \mathbb{R}^n$ and let d be a distance on D. Let $F: D \to \mathbb{R}$ be a response function. The empirical variogram γ is defined by

$$\gamma(\mathbf{d}(\mathbf{X},\mathbf{Y})) = \frac{1}{2} \operatorname{E} \left(|\mathbf{F}(\mathbf{X}) - \mathbf{F}(\mathbf{Y})|^2 |\mathbf{d}(\mathbf{X},\mathbf{Y}) \right) \,.$$

If $\nu \sim T = d(X, Y)$, for an arbitrary Φ it holds $\Phi(t)\gamma(t) \nu(dt) =$

$$\int_{D\times D} \Phi(d(x,y)) \frac{1}{2} |F(x) - F(y)|^2 \ \mu(dx)\mu(dy) \ .$$

The theoretical computation of the variogram for given F and μ is relevant to test the methodological relevance (if any) of this definition. Such a computation is simpler when the distance is of the form d(x, y) = ||x - y||, for some norm on \mathbb{R}^n and the μ is a Lebesgue probability measure, $\mu(dx) = dx$. In such a case, the defining equation becomes, with the change of variables u = x - y and v = x,

 $\Phi(t)\gamma(t) \nu(dt) =$

Parabolic bend: $F(x) = 1 - x^2$



The author was supported by de Castro Statistics and by Collegio Carlo Alberto, Piazza Vincenzo Arbarello 8, 10122 Torino. He is a member of INdAM-GNAMPA and of Enbis. A draft version of the full paper will be posted on the author web-site https://www.giannidiorestino.it and will eventually be uploaded to the arXiv. That version will include a sampling version of the empirical variogram with warranty bounds.

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$\Phi(\|\mathbf{u}\|) \frac{\mathbf{I}}{2} |\mathbf{F}(\mathbf{v}) - \mathbf{F}(\mathbf{u} + \mathbf{v})|^2 \, \mathrm{d}\mathbf{u} \mathrm{d}\mathbf{v} \, .$ JD×D

Here are some immediate properties of the empirical variogram in the norm case.

- 1 If F is constant, then $\gamma = 0$.
- 2 The variogram depends quadratically on the gradient ∇F . In fact,

$$F(v + u) - F(v) = \int_0^1 \nabla F(v + \theta u) \cdot u \, d\theta \, .$$

3 If D =]0, 1[and X, Y are uniform,

$$\gamma(t) = \frac{1}{2(1-t)} \int_0^{1-t} (F(s) - F(s+t))^2 \, ds \, .$$





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Steering Workshop 2020 - STATISTICS AND INNOVATION FOR INDUSTRY 4.0 Florence, FEB 20-21